

Jusang Park

List of Publications by Year in descending order

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430754

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3355
citing authors

#	ARTICLE	IF	CITATIONS
1	Phase transition of a MoS ₂ monolayer through top layer desulfurization by He ⁺ ion irradiation. <i>Journal of Applied Physics</i> , 2022, 131, .	1.1	4
2	Atomic-Layer-Deposition-Based 2D Transition Metal Chalcogenides: Synthesis, Modulation, and Applications. <i>Advanced Materials</i> , 2021, 33, e2005907.	11.1	42
3	Interface Defect Engineering of a Large-Scale CVD-Grown MoS ₂ Monolayer via Residual Sodium at the SiO ₂ /Si Substrate. <i>Advanced Materials Interfaces</i> , 2021, 8, 2100428.	1.9	14
4	2D Transition Metal Dichalcogenide Heterostructures for p- and n-Type Photovoltaic Self-Powered Gas Sensor. <i>Advanced Functional Materials</i> , 2020, 30, 2003360.	7.8	102
5	Synthesis of two-dimensional MoS ₂ /graphene heterostructure by atomic layer deposition using MoF ₆ precursor. <i>Applied Surface Science</i> , 2019, 494, 591-599.	3.1	25
6	Improved Sensitivity in Schottky Contacted Two-Dimensional MoS ₂ Gas Sensor. <i>ACS Applied Materials & Interfaces</i> , 2019, 11, 38902-38909.	4.0	117
7	Textile-based high-performance hydrogen evolution of low-temperature atomic layer deposition of cobalt sulfide. <i>Nanoscale</i> , 2019, 11, 844-850.	2.8	17
8	High-Performance Gas Sensor Using a Large-Area WS ₂ /Se ₂ Alloy for Low-Power Operation Wearable Applications. <i>ACS Applied Materials & Interfaces</i> , 2018, 10, 34163-34171.	4.0	93
9	Recovery Improvement for Large-Area Tungsten Diselenide Gas Sensors. <i>ACS Applied Materials & Interfaces</i> , 2018, 10, 23910-23917.	4.0	115
10	Low-temperature synthesis of 2D MoS ₂ on a plastic substrate for a flexible gas sensor. <i>Nanoscale</i> , 2018, 10, 9338-9345.	2.8	142
11	Catalytic chemical vapor deposition of large-area uniform two-dimensional molybdenum disulfide using sodium chloride. <i>Nanotechnology</i> , 2017, 28, 465103.	1.3	42
12	Characterization of wafer-scale MoS ₂ and WSe ₂ 2D films by spectroscopic ellipsometry. <i>Current Applied Physics</i> , 2017, 17, 1329-1334.	1.1	26
13	Self-Limiting Layer Synthesis of Transition Metal Dichalcogenides. <i>Scientific Reports</i> , 2016, 6, 18754.	1.6	74
14	Comparison of hydrogen sulfide gas and sulfur powder for synthesis of molybdenum disulfide nanosheets. <i>Current Applied Physics</i> , 2016, 16, 691-695.	1.1	15
15	Effect of Al ₂ O ₃ Deposition on Performance of Top-Gated Monolayer MoS ₂ -Based Field Effect Transistor. <i>ACS Applied Materials & Interfaces</i> , 2016, 8, 28130-28135.	4.0	40
16	Improvement of Gas-Sensing Performance of Large-Area Tungsten Disulfide Nanosheets by Surface Functionalization. <i>ACS Nano</i> , 2016, 10, 9287-9296.	7.3	351
17	Uniform, large-area self-limiting layer synthesis of tungsten diselenide. <i>2D Materials</i> , 2016, 3, 014004.	2.0	40
18	Controllable synthesis of molybdenum tungsten disulfide alloy for vertically composition-controlled multilayer. <i>Nature Communications</i> , 2015, 6, 7817.	5.8	188

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19	Nitrogen-doped ZnO/n-Si core-shell nanowire photodiode prepared by atomic layer deposition. <i>Materials Science in Semiconductor Processing</i> , 2015, 33, 154-160.	1.9	19
20	Layer-modulated synthesis of uniform tungsten disulfide nanosheet using gas-phase precursors. <i>Nanoscale</i> , 2015, 7, 1308-1313.	2.8	86
21	Vapor Deposition Techniques for Synthesis of Two-Dimensional Transition Metal Dichalcogenides. <i>Applied Microscopy</i> , 2015, 45, 119-125.	0.8	7
22	Atomic layer deposition of Y ₂ O ₃ and yttrium-doped HfO ₂ using a newly synthesized Y(iPrCp) ₂ (N-iPr-amd) precursor for a high permittivity gate dielectric. <i>Applied Surface Science</i> , 2014, 297, 16-21.	3.1	54
23	Investigation of atomic layer deposition of magnesium oxide on a CoFeB layer for three-dimensional magnetic tunneling junctions. <i>Journal of Alloys and Compounds</i> , 2014, 588, 716-719.	2.8	11
24	Fabrication of Transferable Al ₂ O ₃ Nanosheet by Atomic Layer Deposition for Graphene FET. <i>ACS Applied Materials & Interfaces</i> , 2014, 6, 2764-2769.	4.0	16
25	ZnO homojunction core-shell nanorods ultraviolet photo-detecting diodes prepared by atomic layer deposition. <i>Sensors and Actuators A: Physical</i> , 2014, 210, 197-204.	2.0	17
26	Plasma enhanced atomic layer deposition of magnesium oxide as a passivation layer for enhanced photoluminescence of ZnO nanowires. <i>Journal of Luminescence</i> , 2014, 145, 307-311.	1.5	14
27	Layer-Controlled, Wafer-Scale, and Conformal Synthesis of Tungsten Disulfide Nanosheets Using Atomic Layer Deposition. <i>ACS Nano</i> , 2013, 7, 11333-11340.	7.3	324
28	n-ZnO:N/p-Si nanowire photodiode prepared by atomic layer deposition. <i>Applied Physics Letters</i> , 2012, 100, .	1.5	32